



Appl. No. 10/099,840

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. ....10/099,840  
Confirmation No. ....5306  
Filing Date .....March 12, 2002  
Inventor.....James J. Hofmann  
Assignee.....Micron Technology, Inc.  
Group Art Unit .....2818  
Examiner ..... Hoang, Quoc Dinh  
Attorney's Docket No. ....MI22-1803  
Customer No. ....21567  
Title: Methods of Forming Patterns for Semiconductor Constructions; and Molds  
Configured to Patterned Masses Associated with Semiconductor Constructions

**RESPONSE TO MAY 30, 2003 OFFICE ACTION**

To: Mail Stop Non-Fee Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

From: Robert C. Hyta (Tel. 509-624-4276; Fax 509-838-3424)  
Wells St. John P.S.  
601 W. First Avenue, Suite 1300  
Spokane, WA 99201-3828

**AMENDMENTS**

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